

L Number	Hits	Search Text	DB	Time stamp
17	226	photoresist adj mask adj5 dielectric	USPAT; EPO; JPO	2003/05/14 21:25
21	0	(photoresist adj mask adj5 dielectric) and "densified dielectric"	USPAT;	2003/05/14
25	221	(photoresist adj mask adj5 dielectric) and etch\$3	EPO; JPO	21:24
29	3240	etch\$3 adj3 sidewall	USPAT; EPO; JPO	2003/05/14 21:25
33	10	(photoresist adj mask adj5 dielectric) and (etch\$3 adj3 sidewall)	USPAT; EPO; JPO	2003/05/14 21:25
			USPAT; EPO; JPO	21:30

LKilday_Job_1_of_1

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